

In re Application of:

Seok-Woo LEE

Application No.: 10/648,401

Filed: August 27, 2003

For: METHOD OF FABRICATING TOP  
GATE TYPE THIN FILM TRANSISTOR  
HAVING A LOW TEMPERATURE  
POLYSILICON

Confirmation No.: 5327

Group Art Unit: 2812

Examiner: S. Isaac

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(c), Applicant brings to the attention of the Examiner the documents listed on the attached PTO-1449. This Information Disclosure Statement is being filed after the mailing of a first Office Action, but before the mailing of a final action under § 1.113. Furthermore, each item of information contained in this Information Disclosure Statement was first cited in a Korean Patent Office Search Report (copy enclosed) in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. Therefore, no fee is required for filing this Information Disclosure Statement.

A concise explanation of relevance for each of the non-English language documents listed may be ascertained from the English-language translation of their Abstract. A copy of each listed document is attached. Applicant respectfully requests that the Examiner consider the listed documents and evidence that consideration by making appropriate notations on the attached form.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed documents are material or constitute “prior art.” If it should be determined that the listed documents do not constitute “prior art” under United States law, Applicant reserves the right to present to the Office the relevant facts and law regarding the appropriate status of such documents.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should any of the documents be applied against the claims of the present application.

**Except** for issue fees payable under 37 C.F.R. §1.18, the Commissioner is hereby authorized by this paper to charge any additional fees during the entire pendency of this application including fees due under 37 C.F.R. §§1.16 and 1.17 which may be required,

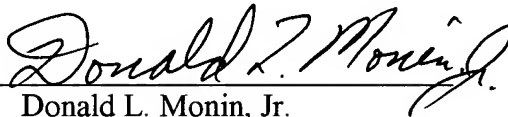
including any required extension of time fees, or credit any overpayment to Deposit Account No.

50-0310. This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR**

**EXTENSION OF TIME** in accordance with 37 C.F.R. §1.136(a)(3).

Respectfully submitted,

**MORGAN, LEWIS & BOCKIUS LLP**

By:   
Donald L. Monin, Jr.  
Reg. No. 47,256

Dated: October 28, 2004

**CUSTOMER NO. 009629**

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DLM/XY/fdb

**INFORMATION DISCLOSURE  
CITATION**

Attorney Docket No.

053785-5148

Application No.:

10/648,401

Applicant: Seok-Woo LEE

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PTO Form 1449

**U.S. PATENT DOCUMENTS****U.S. PATENT APPLICATION PUBLICATION****FOREIGN PATENT DOCUMENTS**

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DLM/XY/fdb

October 28, 2004

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